



US006907305B2

(12) **United States Patent**
Mata et al.

(10) **Patent No.:** **US 6,907,305 B2**
(45) **Date of Patent:** **Jun. 14, 2005**

(54) **AGENT REACTIVE SCHEDULING IN AN
AUTOMATED MANUFACTURING
ENVIRONMENT**

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(*) Notice: Subject to any disclaimer, the term of this
patent is extended or adjusted under 35
U.S.C. 154(b) by 0 days.

(21) Appl. No.: **10/135,145**

(22) Filed: **Apr. 30, 2002**

(65) **Prior Publication Data**

US 2004/0243266 A1 Dec. 2, 2004

(51) **Int. Cl.**⁷ **G06F 19/00**

(52) **U.S. Cl.** **700/99; 700/100; 700/121;**
705/8

(58) **Field of Search** 705/8; 700/99,
700/100, 121, 101

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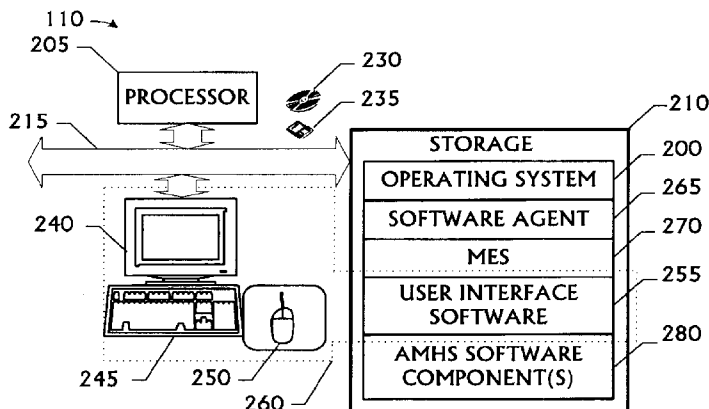
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(57) **ABSTRACT**

A method and apparatus for scheduling in an automated manufacturing environment, comprising are disclosed. The method includes detecting an occurrence of a predetermined event in a process flow; notifying a software scheduling agent of the occurrence; and reactively scheduling an action from the software scheduling agent responsive to the detection of the predetermined event. The apparatus is automated manufacturing environment including a process flow and a computing system. The computing system further includes a plurality of software scheduling agents residing thereon, the software scheduling agents being capable of reactively scheduling appointments for activities in the process flow responsive to a plurality of predetermined events.

53 Claims, 6 Drawing Sheets



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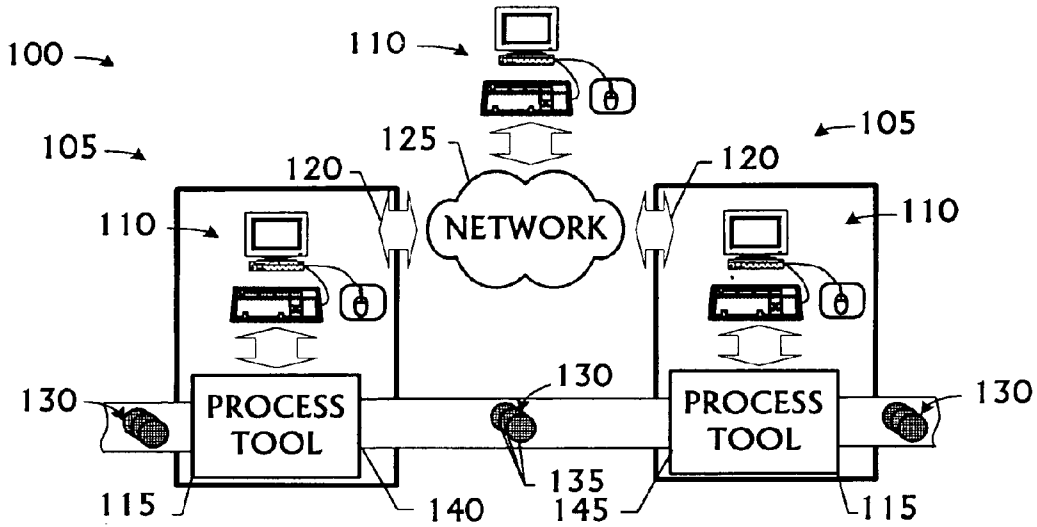


FIG. 1

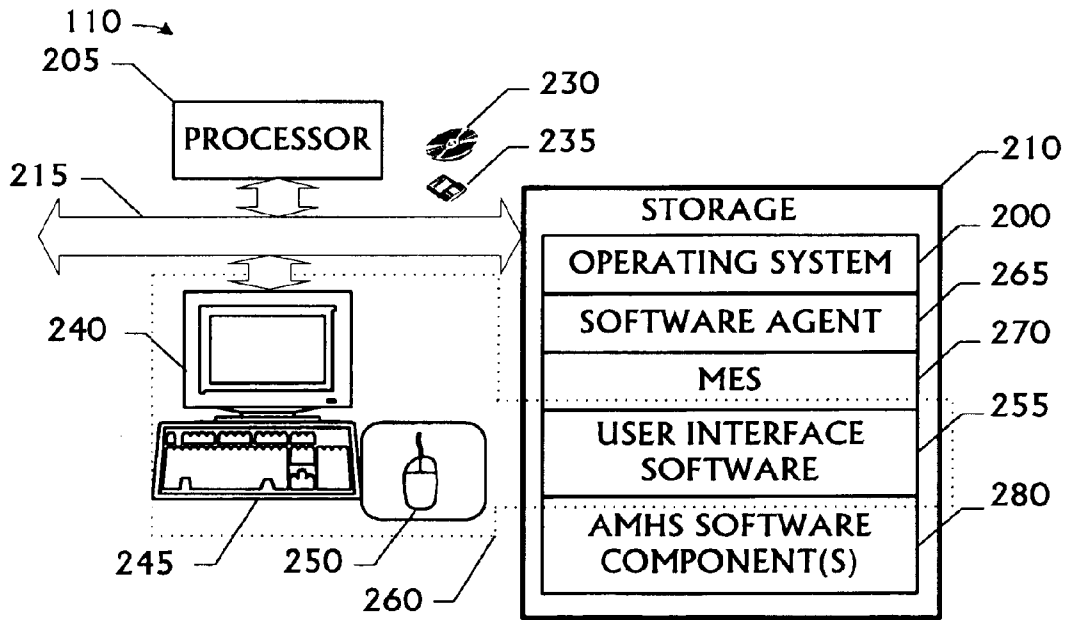


FIG. 2

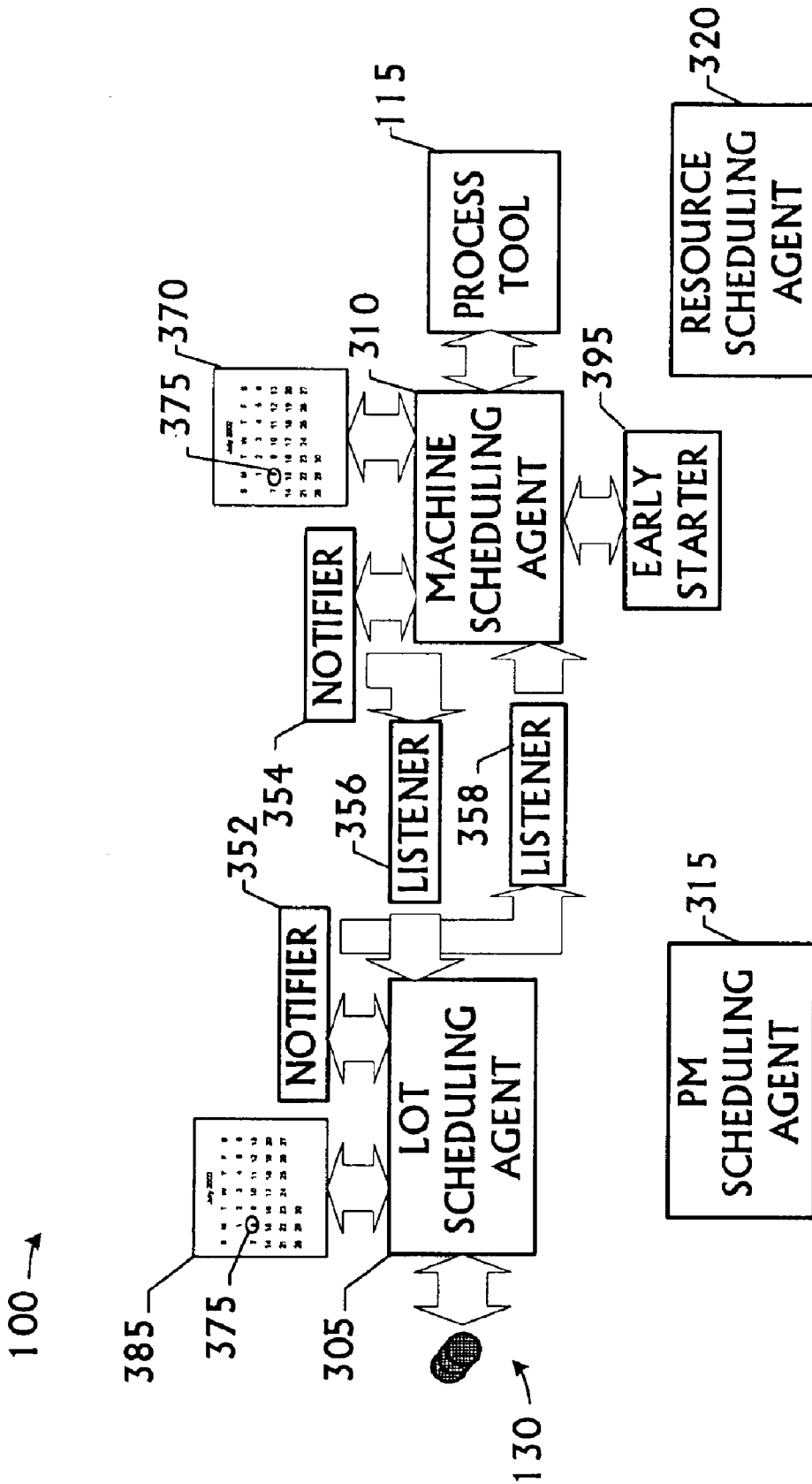


FIG. 3

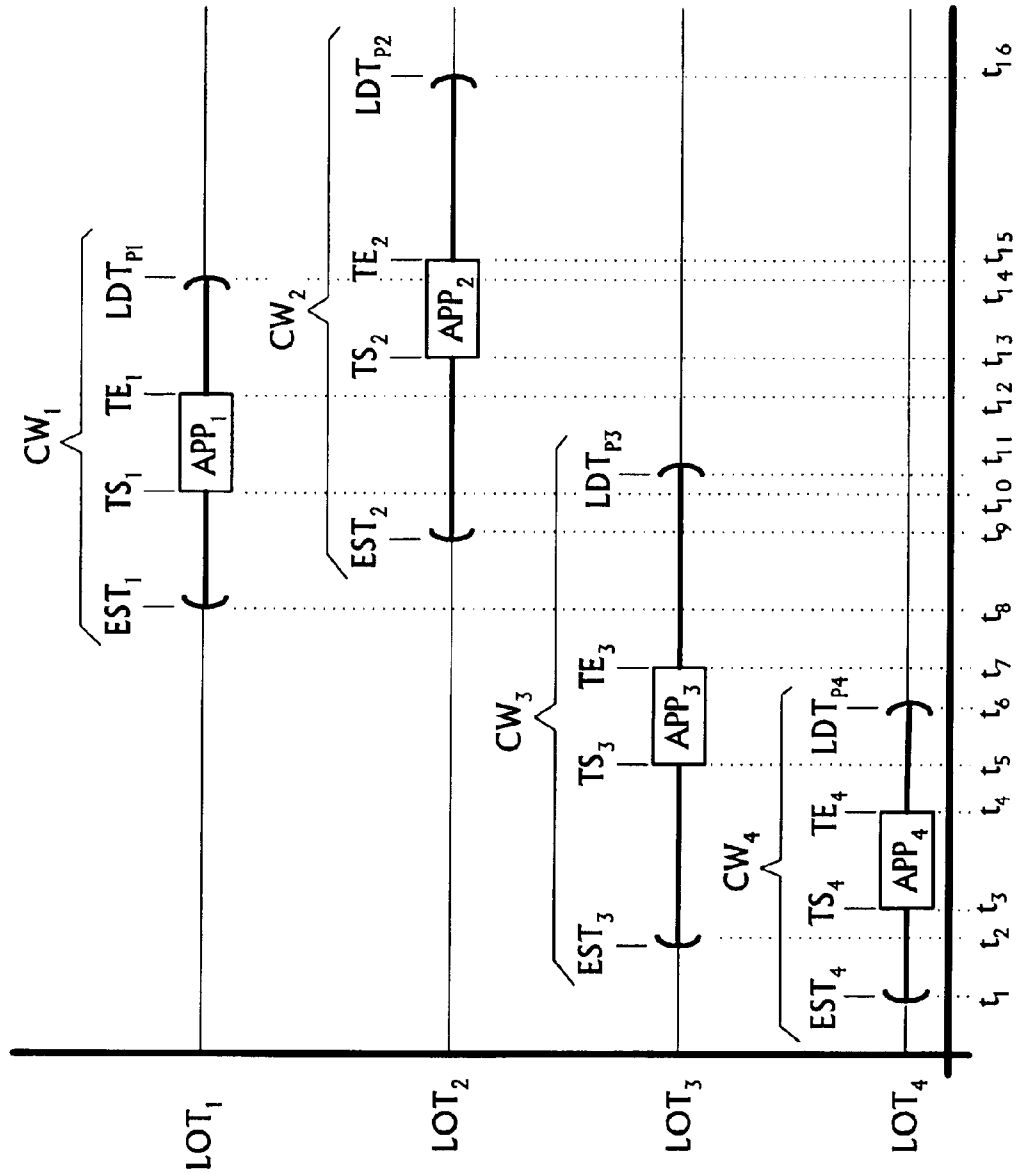


FIG. 4

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